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|--|-----------------------------------|-------------------------------------|
| <b>Form PTO-1449</b><br><br><b>INFORMATION DISCLOSURE CITATION<br/>IN AN APPLICATION</b><br><br><i>(Use several sheets if necessary)</i> | Docket Number 245402008000        | Application Number Not Yet Assigned |
|  | Applicant<br>Tomoki ONO et al.    |                                     |
|  | Filing Date Concurrently Herewith | Group Art Unit Not Yet Assigned     |
|  | Mailing Date November 20, 2003    |                                     |

## U.S. PATENT DOCUMENTS

| Examiner<br>Initials | Ref.<br>No. | Date | Document No. | Name | Class | Subclass | Filing Date If<br>Appropriate |
|----------------------|-------------|------|--------------|------|-------|----------|-------------------------------|
|                      |             |      |              |      |       |          |                               |

## FOREIGN PATENT DOCUMENTS

| Examiner<br>Initials | Ref.<br>No. | Date       | Document No. | Country | Class                     | Subclass | Translation<br>YES NO |
|----------------------|-------------|------------|--------------|---------|---------------------------|----------|-----------------------|
| sy                   | 1.          | 10/06/1989 | JP 01-251775 | Japan   | Discourse in Spectroscopy |          | <del>Abstract</del> ✓ |
| sn                   | 2.          | 07/22/1997 | JP 09-191160 | Japan   | ll                        | ll       | Abstract ✓            |

## OTHER DOCUMENTS (including author, title, Date, Pertinent Pages, Etc.)

| Examiner<br>Initials | Ref.<br>No. | Title |
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